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PATENT APPLICATION

IFW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of:)	
KIYOFUMI SAKAGUCHI, ET AL.)	Examiner: Eduardo A. Rodela
Application No.: 10/540,263)	
Filed: June 23, 2005)	Group Art Unit: 2826
For: SEMICONDUCTOR SUBSTRATE,)	
MANUFACTURING METHOD)	
THEREOF, AND)	
SEMICONDUCTOR DEVICE)	April 17, 2006

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450


RESPONSE TO RESTRICTION REQUIREMENT

Sir:

In response to the Office Action dated March 28, 2005, Applicants provisionally elect the claims of Group II for initial prosecution on the merits; namely, Claims 3-18.

Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should to be directed to our below listed address.

Respectfully submitted,



Attorney for Applicants
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